LIST OF REFERENCES BY APPLICANT	Attorney Docket Number B03-56	Application Number To Be Assigned		
	First Named Inventor Michael J. Sullivan			
	Filing Date September 8, 2003	Examiner To Be	Name Assigned	Group Art Unit To Be Assigned

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EXAMINER INITIAL	Cite No.	Include name of author (in CAPITAL LETTERS), titles of article and/or item, date, page(s), volume and issue numbers, publisher, city and/or country where published					Translation Attached (Y/N)
DAH	BX	Rubber Chemistry and Technology, vol. 74, no. 4, page 688, Sept-Oct 2001					

Examiner Signature Date Considered 1/4/65

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.